(12) INTERNATIONAL APPLICATION PUBLISHED UNDER THE PATENT COOPERATION TREATY (PCT)

(19) World Intellectual Property Organization

International Bureau



(43) International Publication Date 26 February 2004 (26.02.2004)

PCT

(10) International Publication Number WO 2004/017381 A3

(51) International Patent Classification7: 21/36, 29/04

H01L 21/20,

(21) International Application Number:

PCT/US2003/025954

(22) International Filing Date: 19 August 2003 (19.08.2003)

(25) Filing Language:

English

(26) Publication Language:

English

(30) Priority Data: 60/405,085

19 August 2002 (19.08.2002)

- (71) Applicant (for all designated States except US): THE TRUSTEES OF COLUMBIA UNIVERSITY IN THE CITY OF NEW YORK [US/US]; 116th Street and Broadway, New York, NY 10027 (US).
- (72) Inventor; and
- (75) Inventor/Applicant (for US only): IM, James, S. [US/US]; 520 West 114th Street, Apt. 74, New York, NY
- (74) Agents: TANG, Henry et al.; Baker Botts L.L.P., 30 Rockefeller Plaza, New York, NY 10112-4498 (US).

- (81) Designated States (national): AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, SY, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM, ZW.
- (84) Designated States (regional): ARIPO patent (GH, GM, KE, LS, MW, MZ, SD, SL, SZ, TZ, UG, ZM, ZW), Eurasian patent (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European patent (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IT, LU, MC, NL, PT, RO, SE, SI, SK, TR), OAPI patent (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG).

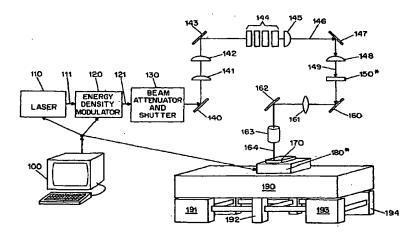
Published:

with international search report

(88) Date of publication of the international search report: 13 May 2004

For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.

(54) Title: PROCESS AND SYSTEM FOR LASER CRYSTALLIZATION PROCESSING OF FILM REGIONS ON A SUB-STRATE TO MINIMIZE EDGE AREAS, AND STRUCTURE OF SUCH FILM REGIONS



(57) Abstract: A process and system for processing a thin film sample (170) are provided. In particular, a beam generator (110) can be controlled to emit at least one beam pulse (111). The beam pulse (111) is then masked to produce at least one masked beam pulse (164), which is used to irradiate at least one portion (510) of the thin film sample (170). With the at least one masked beam pulse (164), the portion (510) of the film sample (170) is irradiated with sufficient intensity for such portion to later crystallize. This portion (510) of the film sample (170) is allowed to crystallize so as to be composed of a first area (518) and a second area (515). Upon the crystallization thereof, the first area (518) includes a first set of grains, and the second area (515) includes a second set of grains whose at least one characteristic is different from at least one characteristic of the second set of grains. The first area (518) surrounds the second area (515), and is configured to allow an active region (618) of a thin-film transistor (TFT) (610) to be provided at a distance therefrom.





INTERNATIONAL SEARCH REPORT

International application No.

PCT/US03/25954

			
A. CLASSIFICATION OF SUBJECT MATTER IPC(7) : H01L 21/20, 21/36, 29/04 US CL : 438/487,482,486,488,481,166; 257/66,69,70,75			
According to International Patent Classification (IPC) or to both national classification and IPC			
B. FIELDS SEARCHED			
Minimum documentation searched (classification system followed by classification symbols) U.S.: 438/487,482,486,488,481,166; 257/66,69,70,75			
Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched NONE			
Electronic data base consulted during the international search (name of data base and, where practicable, search terms used) EAST search terms: thin film sample, mask pattern, crystallize, grains, TFT			
C. DOCUMENTS CONSIDERED TO BE RELEVANT			
Category *	Citation of document, with indication, where a		Relevant to claim No.
Α	US 4,309,225 A (FAN et al.) 05 January 1982 (05.0	1.1982), see entire document.	1-33
A	US 6,169,014 B1 (MCCULLOCH) 02 January 2001 (02.01.2001), see entire document.		1-33
Α	US 5,591,668 A (MAEGAWA et a l.) 07 January 1997 (07.01.1997), see entire document.		1-33
:			
:			
Threshoo	decomposite and listed in the speciment of CD of CD	Samuel Samily	
Further documents are listed in the continuation of Box C.		See patent family annex. "T" later document published after the inte	
Special categories of cited documents:		"T" later document published after the inte date and not in conflict with the applic	
"A" documer defining the general state of the art which is not considered to be of particular relevance		principle or theory underlying the inve	ention
"E" earlier ap	plication or patent published on or after the international filing date	"X" document of particular relevance; the considered novel or cannot be conside when the document is taken alone	
"L" document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified)		"Y" document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is	
"O" document	t referring to an oral disclosure, use, exhibition or other means	combined with one or more other such docu	
"P" document published prior to the international filing date but later than the priority date claimed		"&" document member of the same patent family	
Date of the actual completion of the international search		Date of maine of the management of the management	
23 February 2004 (23.02.2004) Normal and marilling address of the ICA (U.S. Authorized officer 4.4			
Name and mailing address of the ISA/US Mail Stop PCT, Attn: ISA/US		Authorized officer Sharm S. American T. Trans	
Commissioner for Patents		Minhloan T. Tran	
). Box 1450 xandria, Virginia 22313-1450	Telephone No. 703-308-4919	
). (703) 305-3230	_	